

<b>Notice of References Cited</b>	Application/Control No. 10/712,400		Applicant(s)/Patent Under Reexamination GERVAIS ET AL.	
	Examiner Henry S. Hu		Art Unit 1713	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,679,979	01-2004	Gervais et al.	204/252
*	B	US-2001/0005699	06-2001	Morgan et al.	473/376
*	C	US-5,612,407	03-1997	Southwick, Jeffrey G.	524/571
*	D	US-6,100,324	08-2000	Choi et al.	524/493
*	E	US-6,159,657	12-2000	Fleming et al.	430/270.1
*	F	US-6,660,449 B2	12-2003	Zheng et al.	430/270.1
*	G	US-6,399,156 B1	06-2002	Wexler et al.	427/407.1
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	EP-955,687 A2	11-1999	EP	Lim et al.	-----
	O				<i>in IDS of</i>	
	P				<i>10-21-04</i>	
	Q				<i>H1107</i>	
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U				
	V				
	W				
	X				<i>1-13-06</i>

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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